

FORM PTO-1449 (REV. 1-84)		U.S. DEPARTMENT OF COMMERCE PATENT & TRADEMARK OFFICE		CASE NO. 57-17-4-19-14-18		SERIAL NO	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANT: David John Bishop et al.			
				FILING DATE		GROUP	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE IF APPROPRIATE
<i>KJH</i>	AA	6 4 0 9 0 7 2	06/02	Breuer et al.	228	111.5	<i>[Signature]</i>
<i>KJH</i>	AB	6 5 4 1 6 7 6	04/03	Franz et al.	585	250	<i>[Signature]</i>
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
FOREIGN PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	COUNTRY/AUTHOR	CLASS	SUB- CLASS	TRANSL'N YES NO
	AL						
	AM						
	AN						
	AO						
	AP						
OTHER (Including Author, Title, Date, Pertinent Pages, Etc.)							
<i>KJH</i>	AR	Duke et al., "Microfabricated Sieve...", <i>Phys. Rev. Lett.</i> , Vol. 80, No. 7, pp. 1552-1555 (Feb 1998)					
<i>KJH</i>	AS	Burns et al., "An Integrated Nanoliter...", <i>Science</i> , Vol. 282, pp. 484-487 (Oct 1998)					
<i>KJH</i>	AT	Cummings et al., "Continuous Streaming...", <i>7th International Conference on Miniaturized Chemical and Biochemical Analysis Systems</i> , Squaw Valley, CA, pp. 41-44 (Oct 2003) <i>Continuous streaming Dielectrophoretic Particle Filter/Concentrator</i>					
<i>KJH</i>	AU	Jo et al., "Three-Dimensional Micro-Channel...", <i>J. Microelectromech. Syst.</i> , Vol. 9, No. 1, pp. 76-81 (Mar 2000)					
<i>KJH</i>	AV	Wei et al., "Low temperature wafer...", <i>J. Micromech. and Microeng.</i> , Vol. 13, pp. 217-222 (2003)					
<i>KJH</i>	AW	Ma et al., "Low Temperature Bonding...", <i>Final Report 1998-99 for MICRO Project 98-144</i> (3 unnumbered pages), University of California, Davis, CA (Dec 2003)					
<i>KJH</i>	AX	Van Laar, <i>Z. Physik Chem.</i> , Vol. 72, p.723 (1910) [no copy attached]					
EXAMINER: SHEET <u>1</u> OF <u>1</u> <i>KJH</i> DATE CONSIDERED: <i>4/12/06</i>							